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LIS	TOF	REFER	RENCES CITED BY AP	PLICANT	Ravindranath DROOPAD et	: al.			
					FILING DATE		GROUP		
					July 10, 2001		2815		
					U.S. PATENT DOCUMENTS				
EXAMINER INITIAL		·	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE	
·///	1	71/		06/16/92	ISHII ET AL		CLAGG	IF AFFROENIA	
- KY	4)	ZW	5,122,679	05/15/01	WOESTE ET AL		 		
U	-		6,232,806	07/04/95	ITOH ET AL				
		ZX	5,430,397	11/21/00	SUZUKI				
		ZZ	6,151,240 6,528,374	03/04/03	BOJARCZUK, JR ET AL				
	\vdash			07/08/03	DALTON ET AL	-			
		A1	6,589,887	11/12/91	CAMBOU ET AL				
	\vdash	A2	5,064,781 2002/0052061	05/02/02	FITZGERALD			-	
	+	A3		12/09/97	CHAR ET AL				
	1	A4	5,696,392	11/16/99	FUKUSHIMA ET AL				
	+	A5 A6	5,986,301	12/11/01	LIU ET AL			· · · · · · · · · · · · · · · · · · ·	
_	7/_	A7	6,329,277	12/1/01	LIGETAL				
	$\overline{}$	A8							
	\longrightarrow	A9					<u> </u>		
				FO	REIGN PATENT DOCUMENTS		L		
				1			l .	TRANSLATION	
Λ			DOCUMENT NUMBER	DATE	COUNTRY		YES NO		
$\mathcal{U}\Lambda$	\K	ccs	WO 99/67882	12/29/99	WIPO		120	1	
₩ / ·	•/	CCT	WO 95/02904	01/26/95	WIPO				
	1	CCU	WO 02/009150	01/31/02	WIPO				
	\vdash	CCV	0 766 292	04/02/97	EUROPE		 	-	
	+	CCW	198 29 609	01/05/00	GERMANY				
	\top	ССХ	1 069 605	01/17/01	EUROPE				
	1	CCY	0 828 287	03/11/98	EUROPE				
	\top	CCZ	1 176 230	01/30/02	EUROPE				
		L	OTHER RI	FERENCES (Including Author, Title, Date, Perti	inent Pages, e	tc.)		
	╂				Si (100) surface using Sr and SrO fo			SrTiO/sub 2/films" .	
		LLAP	of Vacuum Science &	Technology, V	ol. 20, No. 4, July 2002 (2002-07) pp	o. 1402-1405	-		
	17		XIAMING HU et al; "S	r/Si template fo	ormation for the epitaxial growth of S	rTiO/sub 3/on s	silicon" Mate	erials Research So	
	V	LLAQ	Proceedings, Vol. 716	, 2002, pp. 26	1-266				
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		LLAS	A TALL	X	>	Add	itional Refe	rences sheet(s) att	